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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 1734  
Examiner : Brenda A. Lamb  
Serial No. : 09/628,405  
Filed : August 1, 2000  
Inventors : Ichiro Tanokuchi  
: Sachihiro Iida  
Title : GAS WIPING APPARATUS  
: AND METHOD



22469

PATENT TRADEMARK OFFICE

Docket: 1299-00  
Confirmation No.: 5642  
Dated: November 11, 2002

Commissioner for Patents  
Washington, DC 20231

Sir:

Certificate of Mailing Under 37 CFR 1.8

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